IN THE SPECIFICATION

Please replace the paragraph on page 3, line 33 with the following:

FIGs. 9A, 9B and 9C illustrate another features of sequentially moving the guiding block to position a wafer at a normal position; and

Please replace the paragraph on page 6, line 3 with the following: 8/8/08

Each of the transfer rods 480 is composed of a horizontal portion 482, a vertical portion 484, and a connection portion 486, respectively. The horizontal portion ~~462~~ 482 is linearly connected to the supporting rod 460 by means of a pivotable section on the same plane. The vertical portion 484 perpendicularly extends upwardly from the end of the horizontal portion 482. The connection portion 486 is disposed parallel to the horizontal portion 482, and is pivotally attached to the end of the vertical portion 484. While the horizontal and vertical portions, 482 and 484, may comprise a single body portion, they may also be combined by attachment devices such as screws.

Please replace the paragraph on page 6, line 11 with the following:

FIG. 5 depicts a feature of combining a guiding block and a transfer rod, utilizing, for example, guiding block 300, spacer 140, and transfer rod 480, respectively. Referring to FIGS. 5, 6A and 6B, the connection portions ~~386~~ 486 of the transfer rods 480 are inserted into hollows 124 formed in the sidewalls of the plate 120 under the spacers 140. In each illustrative structure, the guiding block 300 and the transfer rod 480 are combined by means of, for example, a bolt 722 and a nut 724, through openings 302 and 487, to penetrate the center of the guiding block 300 and the end of the connection portion 486. The bolt 722 is coupled to the nut 724 through the opening in the guiding block 300, the holed guiding lane 142 in the spacer 140, and the opening in the connection portion 486 of the transfer rod 480.